राष्ट्रीय प्रौद्योगि की संस्थान सिलचर National Institute of Technology Silchar

(राष्ट्रीयमहत्वकासंस्थान)

(An Institute of National Importance)

Date: 09-08-2024

www.nits.ac.in, Phone: 03842-242914, Fax: 03842-224797, Assam-788010 (INDIA)

Advertisement No.: NITS/Dean(R&C)/ECE/677/01/2024

Applications are invited from Indian citizens for a temporary post of **Junior Research Fellow (JRF)** in the Department of Electronics & Communication Engineering, NIT Silchar, Assam, for the following project.

1 ,	Design and Modeling of Lab-On-Chip based Bio-reactors Capable of Mimicking Human Glomerulus Ultrafiltration and Reabsorption Function of Proximal Tubule of Kidney for in vivo implantation.
Sponsored Agency	Department of Biotechnology (DBT), Government of India
Project sanction number	BT/PR49483/MED/32/922/2023Dated30 May 2024
No. of posts	01(one), Junior Research Fellow (JRF)
Duration	1 year and extendable till the completion of the project (30/11/2025)
Principal Investigator	Dr. Koushik Guha & Prof. K. L. Baishnab, Dept. of Electronics & Comm. Eng.
(P.I & Co-PI)	

General Information and Terms & Conditions

 Essential Qualification and experiences For JRF M.E/M. Tech in ECE/EIE/Biomedical Engineering/	ed branch& specialization cord from a recognized onal level examination by andatory. microfluidics and MEMS lated to the project work.
(Specialization in microfluidics & MEMS) or any allies with minimum 8.0 CGPA and good academic reconstruction of GATE/ NET/National Control government department/agencies/institute is made as a property of the candidate should have experience in working with the post simulation tool, Knowledge of bio-logical background relationships and the post simulation in microfluidics & MEMS) or any allies with minimum 8.0 CGPA and good academic reconstruction. University/Institute. Qualification of GATE/ NET/National Control of CATE/ Net/National Catefornal Control of CATE/ Net/National Catefornal Control of	ed branch& specialization cord from a recognized onal level examination by andatory. microfluidics and MEMS lated to the project work.
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the post simulation tool, Knowledge of bio-logical background rel	ated to the project work.
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3. Salary • Rs.37000/- per month, HRA along with other allow	zancos /incroment will be
	ances/ nicrement will be
provided as per project/ institute Norms.	·
4. Last date of receiving/ 29 August, 2024	
Submission of filled	
up application form	
5. Reporting Applicants are requested to submit the signed scanne	ed copy of their filled-in
application form along with CV and the all supporting	
through email at koushik@ece.nits.ac.in with subject	
post of JRF under DBT project BT/PR49483/ MED/32/9	, ,
short listed candidates will be sent through email.	7,7020
6. Date of interview, time, Interview date and mode (online/offline) will be notified	ed in due course of time
And venue through email.	
7. No objection certificate Employed candidates are to submit no objection certificate	cate from his/her
Employer at the time of interview.	
8. Institute right The Institute has the discretion to restrict the number of	of candidates to be called
for the interview on the basis of screening. No cand	didate may be recruited
suitable candidates are not found.	-
9. Signing of the Selected candidates shall have to sign an agreement at	the time of
agreement Joining.	

Associate Dean (R&C)

NIT Silchar.

National Institute of Technology Silchar

FORMAT of APPLICATION

Paste recent passport size colored photograph

for Junior Research Fellow (JRF)

1.	Advertisement no				
2.	Title of the Project				
3.	Department:				
4.	Name of the applicant (in block letters):				
5.	Father's/Husband's Name:				
6.	Date of Birth (DD-MM-YYYY):				
7.	Age as on 29.08.2024				
8.	Postal Address:				
	E-mail: Phone no.:				
9.	Permanent Address:				
10.	Nationality:				
11.	Marital Status:				
12.	12. Whether belongs to SC/ST/PH/OBC: (If yes, attach certificate):				
13.	Educational Qualification: (Starting from Class X)				

Exam. passed	Board/ University	Division	% age of marks/ CPI	Year of passing	Subjects

14	NET	/GATE	Examina	ations	Passed
тт.	TALL			ations	I asscu

I. NET			II.	GATE	
Subject	Qualifying date	Valid upto	Subject	Score	Valid upto

15. Details of employments:

Sl. No.	Name of the Organization	Name of the post	Period	Scale of pay and present pay	Nature of duty

16. Any other relevant information that you may like to furnish:

Declaration

I declare that the a	nbove information	n are true and	l correct to the	e best of my	knowled	dge and	belief.

Date:	
Place	Signature of the applicant